

--LITHOGRAPHIC METHOD AND APPARATUS

B1

ABSTRACT OF THE DISCLOSURE--;

Line 2, change "comprises" to --includes--.

IN THE SPECIFICATION:

Please amend the specification as follows.

Page 1, before line 1, on separate lines, please insert:

--BACKGROUND OF THE INVENTION

1. Field of the Invention--;

line 1, change "apparatus, in particular" to --apparatus--;

line 2, change "exposure. More particularly, the invention relates" to
--exposure, and more particularly--;

line 3, change "apparatus comprising:" to --apparatus.--;

lines 4-8, delete these lines entirely;

before line 9, on a separate, line insert:

--2. Discussion of Related Art--;

line 20, change "apparatus" to --apparatuses--;

line 22, change "apparatus" to --apparatuses--.

Page 2, before line 31, insert on a separate line:

--BRIEF SUMMARY OF THE INVENTION--.

B4

Page 3, before line 34, insert on a separate line:

--BRIEF DESCRIPTION OF THE DRAWINGS--.

B5

Page 4, before line 15, insert on a separate line:

--DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS--.

Page 5, line 8, change "Fig. 2 shows" to --Figs. 2(a)-2(d) show.

Page 11, line 12, change "Referring" to --With reference--.

Page 14, first line, change "CLAIMS:" to --WE CLAIM:--

IN THE CLAIMS:

Please amend the claims as follows.